Notice of References Cited Application/Control No. 10/613,497 Examiner Betelhem Shewareged Applicant(s)/Patent Under Reexamination CHEN, TIENTEH Page 1 of 1

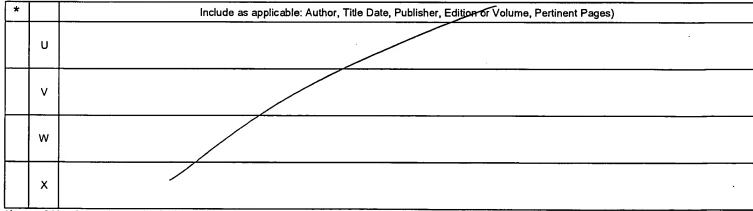
U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,183,844 B1	02-2001	Li, Huawen	428/32.25
	В	US-6,406,143 B1	06-2002	Chen et al.	347/105
	С	US-2005/0003113 A1	01-2005	Chen et al.	428/032.18
	D	US-2003/0186003 A1	10-2003	Nakano et al.	428/32.1
	Е	US-			<u>. </u>
	F	US-			
	G	US-			
	Н	US-			
	1	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	· Name	Classification
	N					
	0					
	Р					
	Œ					
	R					·
	S			•		
	Τ					

NON-PATENT DOCUMENTS



*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.